

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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| In re Application of: | Tsuyoshi MATSUDA; Tatsuhiko HIRANO; Junhui OH; Atsunori KAWAMURA; Kenji SAKAI |
| Application No.: | 10/574115 |
| Filed: | July 24, 2006 |
| For: | POLISHING COMPOSITION AND POLISHING METHOD |
| Examiner: | Mr. Gary Simonds |
| Group Art Unit: | 1793 |

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Docket No.: O11.2I-13210-US01

AMENDMENT

This Amendment is in response to the Office Action dated **April 10, 2008**.

An extension of time is required to make this response timely. If no separate petition is enclosed, Applicants hereby petition for an extension of time sufficient to make the response timely. In the event that this response requires the payment of government fees and payment is not enclosed, please charge Deposit Account No. 22-0350.

Please amend the application as follows: